

<u>Set Name</u> side by side	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR			
<u>L21</u>	jp-01245444-\$.did. or jp-04263140-\$.did. or jp-08203131-\$.did. or ep-907165-\$.did.	7	<u>L21</u>
<u>L20</u>	jp-01245444-\$.did. or jp-04263140-\$.did. or jp-08203131-\$.did. or wo-9837556-\$.did.	7	<u>L20</u>
<u>L19</u>	I14 not L18	120	<u>L19</u>
<u>L18</u>	L17 and I14	44	<u>L18</u>
<u>L17</u>	((absorptive or absorption or absorb\$4) near10 (light or laser))	165289	<u>L17</u>
<u>L16</u>	((absorbing or absorption or absorb) near10 (light or laser))	129183	<u>L16</u>
<u>L15</u>	L14 and I7	20	<u>L15</u>
<u>L14</u>	L13 and I4	164	<u>L14</u>
<u>L13</u>	((resist\$1 or photoresist\$1) same ((ar or arc or antireflect\$6 or nonreflect\$6 or ((non or anti) near2 reflect\$6)) near5 (film or layer\$1)))	5091	<u>L13</u>
<u>L12</u>	jp-04263140-\$.did.	1	<u>L12</u>
<u>L11</u>	jp-05263140-\$.did.	2	<u>L11</u>
<u>L10</u>	((resist\$1 or photoresist\$1) same ((ar or arc or antireflection or (anti near2 reflect\$6)) near5 (film or layer\$1)))	4523	<u>L10</u>
<u>L9</u>	L8 and I4	103	<u>L9</u>
<u>L8</u>	L7 and I6	1374	<u>L8</u>
<u>L7</u>	((resist\$1 or photoresist\$1) same ((absorbing or absorption or absorb) near10 (light or laser)))	3653	<u>L7</u>
<u>L6</u>	((resist\$1 or photoresist\$1) same ((absorbing or absorption or absorb) near5 (film or layer\$1)))	2999	<u>L6</u>
<u>L5</u>	L4 and I3	4	<u>L5</u>
<u>L4</u>	((optical or laser or information) near5 (master\$6 or medium or media or disk\$1 or disc\$1))	383731	<u>L4</u>
<u>L3</u>	((resist\$1 or photoresist\$1) same ((antihalation or halation) near5 (film or layer\$1)))	198	<u>L3</u>
<u>L2</u>	WO-200269336-\$.did.	1	<u>L2</u>
<u>L1</u>	us-20020160312-\$.did.	2	<u>L1</u>

END OF SEARCH HISTORY